



**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT PTO-1449**

Docket No. <b>52433/801</b>	Application No. <b>10/540,628</b>
Applicant(s) <b>Tatsuo Yokoi, et al.</b>	Examiner <b>YEE, DEBORAH</b>
Filing Date <b>June 23, 2005</b>	Confirmation No. <b>6709</b>
	Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	2001-60651	07/07/2001	KR			Abstract	
	08-269538	10/15/1996	JP			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Korean Office Action dated February 19, 2009 issued in corresponding Korean Application No. 10-2007-7007574.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	